



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the Application of
Shinji KISHIMURA, et al.

Serial No.: 10/034,366
Filed: January 03, 2002

: Customer Number: 20277
: Confirmation Number: 8700
: Group Art Unit: 1756
: Examiner: DABORAH CHACKO DAVIS

For: PATTERN FORMATION MATERIAL AND PATTERN FORMATION METHOD

8/3/03
#6/selection

RESPONSE TO RESTRICTION REQUIREMENT

Mail Stop Restriction Requirement
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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SEP 02 2003
GROUP 1700

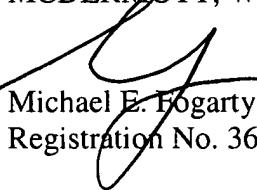
Sir:

Noting the Office Action of August 1, 2003 wherein restriction has been required, Applicant(s) hereby elect Group II (claims 6-25, drawn to a pattern formation method) for prosecution in the above-identified application.

To the extent necessary, a petition for an extension of time under 37 C.F.R. 1.136 is hereby made. Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

MCDERMOTT, WILL & EMERY


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Date: August 28, 2003